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**CONFIRMATION NO. 2699** 

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SERIAL NUMBER 10/617,035	FILING DATE 07/11/2003 RULE	C	CLASS 257	GROUP ART UNIT 2815		UNIT	ATTORNEY DOCKET NO. NEG-176 US-2DV	
APPLICANTS								
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** CONTINUING DATA **********************************								
** FOREIGN APPLICATIONS ************************************								
IF REQUIRED, FORE ** 09/03/2003	EIGN FILING LICENSE	GRANTE	D					
Foreign Priority claimed 35 USC 119 (a-d) conditions	X yes ☐ no  Met afte	er	STATE OR	SHE	ETS	тот	AL	INDEPENDENT
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ADDRESS 21254 MCGINN & GIBB, PL 8321 OLD COURTHO SUITE 200 VIENNA , VA 22182-3817								
TITLE Active matrix substrat	e and manufacturing me	ethod the	erefor					
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1158		Other
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